

<b>INFORMATION DISCLOSURE STATEMENT</b> <b>PTO-1449 (PAGE 1 OF 1)</b>	SERIAL NUMBER	DOCKET NO. P57054
	APPLICANT Sung-Hoon Kim et al.	
	FILING DATE 19 April 2004	GROUP

U.S. PATENT DOCUMENTS						
EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
DL	2004/0048601	3/04	Lee et al.			
	2003/0078047	4/03	Lee et al.			
	2003/0069013	4/03	Lee et al.			
	6,704,569	3/04	Larson			
	6,697,621	2/04	Taha et al.			
	6,687,243	2/04	Sayers et al.			
	to be assigned	4/04	Lee			
↓	to be assigned	4/04	Lee et al.			

FOREIGN PATENT DOCUMENTS						TRANSLATION	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						

EXAMINER: /Daniel Lai/	DATE CONSIDERED: 03/07/2007
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# INFORMATION DISCLOSURE STATEMENT

PTO-1449 (PAGE 1 OF 1)

MAY 01 2006

SERIAL NUMBER 10/826,370

DOCKET NO. P57054

APPLICANT SUNG-HOON KIM, *et al.*

FILING DATE 19 April 2004

GROUP 2665

## U.S. PATENT DOCUMENTS

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE

## FOREIGN PATENT DOCUMENTS

## TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
DL	CH 1325238	12/01	CHINA			Abstract	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

DL	Chinese Office Action of the Chinese Patent Application No. 2004-10032956.6, mailed on 17 March 2006

EXAMINER: /Daniel Lai/ DATE CONSIDERED: 03/07/2007

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	<b>APPLICANT</b> SUNG-HOON KIM, <i>et al.</i>	
	<b>FILING DATE</b> 19 April 2004	<b>GROUP</b> 2665

U.S. PATENT DOCUMENTS							
EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
FOREIGN PATENT DOCUMENTS						TRANSLATION	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
DL	JP 2003-111124	04/03	JAPAN			Abstract	
↓	JP 08-214358	08/96	JAPAN			Abstract	
	JP 07-023463	01/95	JAPAN			Abstract	
	JP 2002-540649 (w/ WO00/44152 abstract)	11/02	JAPAN			Abstract	
↓	JP 11-252612	09/99	JAPAN			Abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
DL	Japanese Office Action of the Japanese Patent Application No. 2004-136615, mailed on 20 June 2006						
<b>EXAMINER:</b> /Daniel Lai/			<b>DATE CONSIDERED:</b> 03/07/2007				
<small>EXAMINER: Initial if reference considered. whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							